

**Development support for intelligent systems : test, evaluation, and analysis of microservices**

Perbandt, Charline von; Tyca, Matthias; Koschel, Arne; **Astrova, Irina** Intelligent systems and applications : proceedings of the 2021 Intelligent Systems Conference (IntelliSys). Volume 1 2022 / p. 857-875 [https://doi.org/10.1007/978-3-030-82193-7\\_58](https://doi.org/10.1007/978-3-030-82193-7_58) [Conference proceedings at Scopus](#) [Article at Scopus](#)

**Education environment for electronics and microsystems**

**Ajaots, Mairo; Min, Mart; Rang, Toomas; Ubar, Raimund-Johannes** Microelectronics education : proceedings of the European Workshop, Grenoble, France, 5-6 Feb 1996 1996 / p. 145-148: ill

**Education environment for electronics and microsystems**

**Ajaots, Mairo; Min, Mart; Rang, Toomas; Ubar, Raimund-Johannes** First European Workshop on Microelectronics Education, Villard de Lans, France, February 5-6, 1996 : proceedings 1996 / p. 39

**Electroless Ni-P-MoS<sub>2</sub>-Al<sub>2</sub>O<sub>3</sub> composite coating with hard and self-lubricating properties**

Mohanty, Shalini; Jamal, Naghma; Das, Alok Kumar; **Prashanth, Konda Gokuldoss** Materials 2022 / art. 6806 <https://doi.org/10.3390/ma15196806> [Journal metrics at Scopus](#) [Article at Scopus](#) [Journal metrics at WOS](#) [Article at WOS](#)

**Mask-defined abrasive-jet micromachining**

**Kruusing, Arvi**; Leppävuori, Seppo; Uusimäki, Antti; Uusimäki, M. MICRO SYSTEM Technologies 98 : 6th International Conference and Exhibition on Micro Electro, Opto, Mechanical Systems and Components : Potsdam, Germany, December 1-3, 1998 1998 / p. 673-675

**Microfabrication of biomedical lab-on-chip devices : a review**

**Giannitsis, Athanasios** Estonian journal of engineering 2011 / p. 109-139 : ill

**Micromachining of magnetic materials**

**Kruusing, Arvi**; Leppävuori, Seppo; Uusimäki, Antti; Petretis, Br.; Makarova, O. Sensors and actuators 1999 / 1/3, p. 45-51

**Mikro- ja nanotehnoloogiliste uurimismeetodite arendamine tööstuslike materjalide väljatöötamiseks : kommentaar Eesti Vabariigi teaduse aastapreemia pälvinud tööde tsüklile**

**Kübarsepp, Jakob**; Lõhmus, Ants; **Hussainova, Irina**; Lõhmus, Rünno Tallinna Tehnikaülikooli aastaraamat 2005 2006 / lk. 269-284

**Reliability in microsystems**

Michel, Bernd; Schubert, A.; Reichl, H. BEC'96 : the 5th Biennial Baltic Electronics Conference, October 7-11, 1996, Tallinn, Estonia : proceedings 1996 / p. 37-40: ill

**Research of permanent magnet microfabrication technology and electromagnetic microdevices at Tallinn Technical University**

**Kruusing, Arvi; Podgurski, Vitali** Proceedings of the Third Micro Structure Workshop : March 24-25, 1998 1998 / p. 71-78

**Technonomics of manufacturing of silicon microsystems on WSI**

Bubennikov, Alexander N.; Bubennikov, Alexander A. BEC'98 : the 6th Biennial Conference on Electronics and Microsystems Technology, October 7-9, 1998, Tallinn, Estonia : proceedings 1998 / p. 29-32: ill